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| <b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br><i>(use as many sheets as necessary)</i> |   |           |   | <b>Application Number</b>     | 09/853,370        |
|  |   |           |   | <b>Filing Date</b>            | 05-11-2001        |
|  |   |           |   | <b>First Named Inventor</b>   | Donald S. Gardner |
|  |   |           |   | <b>Art Unit</b>               | 2832              |
|  |   |           |   | <b>Examiner Name</b>          | Not yet assigned  |
| <b>Sheet</b>   | 1 | <b>of</b> | 4 | <b>Attorney Docket Number</b> |                   |
| 42390P11265  |   |           |   |                               |                   |

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|-----------------------|--------------|--------------------|----------|
| Examiner<br>Signature | Troye Nguyle | Date<br>Considered | 10/19/09 |
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Sheet

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| Application Number     | 09/853,370        |
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| Attorney Docket Number | 42390P11265       |

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|--|-----------------------|--|----------------|
| O P E<br>TTPX<br>JUN 7 2002<br>PATENT & TRADEMARK OFFICE |                       | K. SHIRAKAWA, ET AL., "Thin Film Cloth-Structured Inductor For Magnetic Integrated Circuit," IEEE Transactions on Magnetics, September 1990, pp. 2262-2264, Vol. 26, No. 5.  | /              |
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Examiner Signature

Tuyen Nguyen

Date Considered

10/19/02

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|--------------------|---|--|----------------|
| <i>OKP/E</i>       | JUN 17 2002<br>PATENT & TRADEMARK OFFICE<br>SCA | Y. KOBAYASHI, ET AL., "New Type Micro Cloth-Inductor And Transformer With Thin Amorphous Wires And Multi-Thin Coils," IEEE Transactions on Magnetics, September 1992, pp. 3012-3014, Vol. 28, No. 5.   | /              |
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|                    |   | T. SATO, ET AL., "New Applications of Nanocrystalline Fe(Co-Fe)-Hf-O Magnetic Films To Micromagnetic Devices," Journal of Applied Physics, June 1, 1998, pp. 6658-6660, Vol. 83, No. 11.   | /              |
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|                    |   | <u>JOACHIM N. BURGHARTZ</u> , "Progress In RF Inductors On Silicon - Understanding Substrate Losses," IBM Research Division, Yorktown Heights, NY.   | /              |
| <i>TTN</i>         |   | S. YABUKAMI, ET AL., "Noise Analysis Of A MHz-3 GHz Magnetic Thin Film Permeance Meter," Journal of Applied Physics, April 15, 1999, pp. 5148-5150, Vol. 85, No. 8.  | /              |
|                    |   | <u>JAE PARK and MARK G. ALLEN</u> , "Bar-Type Microinductors and Microtransformers With Electroplated Alloy Cores," Magnetic Devices Research, sponsored by Packaging Research Center.   | /              |

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|-----------------------|---------------|--------------------|----------|
| Examiner<br>Signature | Taylor Nguyen | Date<br>Considered | 10/19/02 |
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| OIP               | JUN 17 2002 SCAP | ERIK BRANDON, "System On A Chip Integrated Passive Components (uIRS)"  |                |
|                   |                  | MASAHIRO YAMAGUCHI, "Magnetic Films For Planar Inductive Components And Devices," Handbook of Thin Film Devices, edited by M.H. Francombe, 2000, pp. 185-186, Vol. 4: Magnetic Thin Film Devices.  |                |
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Examiner  
Signature*Taylor Nguyl*Date  
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